

I21 I05  
Dicing  
4-1-02

## PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

1C857 U.S. PTO  
10/068534  
02/06/02



Applicant : Ming Michael Li  
Filed : February 6, 2002  
For : FORMATION OF MICRO ROUGH POLY SURFACE  
FOR LOW SHEET RESISTANCE SALICIDED SUB-  
QUARTER MICRON POLY LINES  
Docket No. : 97-P-149D1 (850063.518D1)  
Date : February 6, 2002

Box Patent Application  
Commissioner for Patents  
Washington, DC 20231

INFORMATION DISCLOSURE STATEMENT

## Commissioner for Patents:

In accordance with 37 C.F.R. §§ 1.56 and 1.97 through 1.98, applicant wishes to make known to the Patent and Trademark Office the references set forth on the attached form PTO-1449. This application relies, under 35 U.S.C. § 120, on the earlier filing date of prior Application No. 09/126,960, filed July 31, 1998. The references listed on the attached Form PTO-1449 were submitted to and/or cited by the Patent and Trademark Office in this prior application and, therefore, are not required to be provided in this application. If the Examiner wishes, copies will be provided upon request. As to any reference supplied, applicant does not admit that it is "prior art" under 35 U.S.C. §§ 102 or 103, and specifically reserves the right to traverse or antedate any such reference, as by a showing under 37 C.F.R. § 1.131 or other method. Although the aforesaid references are made known to the Patent and Trademark Office in compliance with applicant's duty to disclose all information he is aware of which is believed relevant to the examination of the above-identified application, applicant believes that his invention is patentable.

Please acknowledge receipt of this Information Disclosure Statement and kindly make the cited references of record in the above-identified application.

Respectfully submitted,  
Ming Michael Li  
Seed Intellectual Property Law Group PLLC

*E. Russell Tarleton*

E. Russell Tarleton  
Registration No. 31,800

ERT:aep

Enclosures:  
Form PTO-1449

701 Fifth Avenue, Suite 6300  
Seattle, Washington 98104-7092  
Phone: (206) 622-4900  
Fax: (206) 682-6031

D:\NrPortb\iManage\JASONA\253362\_1.DOC

#2/105  
DKing  
4-1-02  
Sheet 1 of 1

FORM PTO-1449 (REV.7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 97-P-149D1 (850063.518D1)	EXPRESS MAIL NO. EL897859635US
<b>INFORMATION DISCLOSURE STATEMENT</b> <i>(Use several sheets if necessary)</i>		APPLICANT Ming Michael Li			
		FILING DATE February 6, 2002	GROUP ART UNIT		

### U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AA	5,182,232	01/26/93	Chhabra et al.	437	200	10/06/02
AB	5,394,012	02/28/95	Kimura	257	739	10/06/02
AC	5,418,188	05/23/95	Harper et al.	437	200	10/06/02
AD	5,585,295	12/17/96	Wu	437	44	10/06/02
AE	5,599,746	02/04/97	Lur et al.	437	200	10/06/02
AF	5,767,013	06/16/98	Park et al.	438	622	
AG	5,877,063	03/02/99	Gilchrist	438	398	
AH	5,993,685	11/30/99	Currie et al.	252	79.1	
AI	6,074,926	06/13/00	Cathey et al.	438	398	
AJ						

### FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
	AK					
	AL					
	AM					
	AN					
	AO					

### OTHER PRIOR ART *(Including Author, Title, Date, Pertinent Pages, Etc.)*

AP	Chang, C.Y. and Sze, S.M., "ULSI Technology," 1996, The McGraw-Hill Companies, Inc., pp. 229, 395-397
AQ	Wolf, S., "Silicon Processing for the VLSI Era," Vol. 2 – Process Integration, 1990, Lattice Press, pp. 45, 354-357
AR	

EXAMINER	DATE CONSIDERED

\* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).